

Electronic Acknowledgement Receipt

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Application Number:	10604514
Confirmation Number:	1513
Title of Invention:	WAFER HOLDER FOR SEMICONDUCTOR MANUFACTURING DEVICE AND SEMICONDUCTOR MANUFACTURING DEVICE IN WHICH IT IS INSTALLED
First Named Inventor:	Masuhiro Natsuhara
Customer Number:	29453
Filer:	James Judge
Filer Authorized By:	
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment - After Non-Final Rejection	SM020_Reply_1stOA_CE.pdf	145110	no	9

Warnings:	
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